

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/817,412	RYKEN ET AL.		
Examiner	Art Unit		
Shih-Chao Chen	2821		

SEARCHED					
Class	Subclass	Date	Examiner		
343	700MS, 846, 850, 853	5/16/2005	CHEN		
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
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	Subclass	Subclass Date			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST (See attached printout).	5/17/2005	CHEN	